

Notice of References Cited	Application/Control No. 10/520,473	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Archene Turner	Art Unit 1775	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,830,813 A	11-1998	Yao et al.	51/307
*	B	US-6,120,570 A	09-2000	Packer et al.	51/309
*	C	US-6,106,957 A	08-2000	Fang, Zhigang	75/246
*	D	US-5,697,994	12-1997	Packer et al.	428/698
*	E	US-5,512,235 A	04-1996	Cerutti et al.	75/236
*	F	US-4,647,546	03-1987	Hall et al.	51/309
*	G	US-4,518,659	05-1985	Gigl et al.	75/244
*	H	US-4,343,651	08-1982	Yazu et al.	75/239
*	I	US-4,334,928	06-1982	Hara et al.	75/244
*	J	US-4,224,380	09-1980	Bovenkerk et al.	51/309
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	1006093	06-2000	EP	Sumitomo	--
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	English abstract of KR 2001004887 (patent published 1-2001)
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.